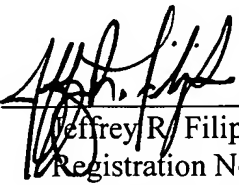


REMARKS

This Preliminary Amendment is presented in order to: (1) add identifying data to the top of page 1 of the specification and make a minor editorial amendment to the specification; (2) incorporate the changes made in the International Application under Article 34; and (3) cancel sheet 6/6 of the drawings, which contains only a list of the "Reference marks in the drawings."

Respectfully submitted,

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Reference marks in the drawings

-
- 10 Reactor chamber
 - 20 Silicon wafer
 - 30 B_2H_6 gas
 - 40 ECR plasma source
 - 45 Plasma
 - 50 Wafer susceptor
 - 60 RF power supply
 - 100 Plasma doping apparatus
 - 101 High-frequency power supply
 - 102 Matching box
 - 103 Coil and antenna
 - 104 Mass-flow controller
 - 105 Mass-flow controller
 - 106 Turbo pump
 - 107 Conductance valve
 - 108 Dry pump
 - 109 Circulator
 - 110 DC power supply
 - 111 Matching box
 - 112 High-frequency power supply
 - 113 Target
 - 114 Susceptor
 - 115 Reactor chamber
 - 116 Glass member
 - 401, 402 Plotted line indicating the relation between
voltage application time and sheet resistance